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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Takashi IZUTA

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Serial No. : 10/806,885

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For : SUBSTRATE TREATING METHOD AND APPARATUS

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

**STATUS INQUIRY LETTER**

Sir:

We filed the above application with the U.S. Patent and Trademark Office on March 22, 2004. As of this date, we have not received a first Office Action from the Patent Office. Kindly advise us of the status of this application.

Respectfully submitted,

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